

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

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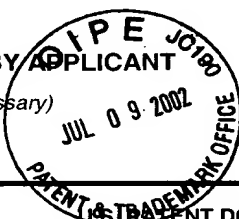
Conant et al.

FILING DATE

May 31, 2000

GROUP

2872



PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)

TECHNOLOGY CENTER 2800

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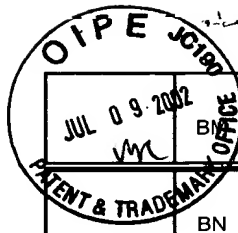
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FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

WR	BA	Kam Y. Lau, "Microscanner Raster-scanning Display: A Spyglass for the Future", Optics & Photonic News, May 1999 Vol. 10 No. 5, pages 47-50, 84
WR	BB	Nee et al. "Stretched-Film Micromirrors For Improved Optical Flatness", IEEE MEMS 2000 Conference, January 23-27 2000, Miyazaki, Japan
WR	BC	Conant et al. "Robustness and Reliability of Micromachined Scanning Mirrors", MOEMS 1999, Mainz Germany, August 1999
WR	BD	Hagelin et al. "Integrated Micromachined Scanning Display Systems", presented at 18 th Congress of the International Commission for Optics, San Francisco, CA, August 1999
WR	BE	Conant et al. "A Raster-Scanning Full-Motion Video Display Using Polysilicon Micromachined Mirrors", proc. Transducers '99, Sendai, Japan, June 1999, pp. 376-379
WR	BF	Hart et al. "Time-Resolved Measurement of Optical Mems Using Stroboscopic Interferometry", proc. Transducers '99, Sendai, Japan, June 1999, pp. 470-473
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WR	BH	Nee et al. "Scanning Blazed-Grating for High-Resolution Spectroscopy", 1998 Workshop for Solid State Sensors and Actuators (HH '98) Late News Poster Session Supplemental Digest, Hilton Head Island, June 8-11, 1998, pgs. 9-10
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WR	BJ	Nee et al. "Lightweight, Optically Flat Micromirrors for Fast Beam Steering", IEEE/LEOS Optical MEMS 2000, Kauai, Hawaii, August 21-24, 2000
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WML	BN	Yoon et al. "Use of High-Field Electrical Testing for SIMOX BOX Metrology", in Proceedings of 1995 IEEE International SOI Conference, Tucson, AZ, USA, October 3-5, 1995, pp. 146-147
WML	BN	Yap et al. "A Model for High-Field Conduction In Simox Buried Oxides", in Proceedings of 1994 IEEE International SOI Conference, Nantucket, MA, USA, October 3-6, 1994, pp. 93-94
WML	BO	Hyodo et al., "An HDR System Hydraulics Model and Detailed Analysis of the 1991 Circulation Test at the Hijiori HDR Site, Japan", Geothermal Resources Council Transactions, Vol. 198, October 1995, pgs 263-268
WML	BP	Hyodo et al., "An HDR System Hydraulics Model and Analysis of the 1995 Preliminary Circulation Test at the Hijiori HDR Site of the NEDO Project, Japan", Twentieth Stanford Workshop on Geothermal Reservoir Engineering, pgs 23-24
WML	BQ	Wright et al., "Hydraulic Fracture Orientation and Production/Injection Induced Reservoir Stress Changes in Diatomite Waterfloods", Society of Petroleum Engineers, pages 139-151
WML	BR	Hoon et al, "A Model for SIMOX Buried-Oxide High-Field Conduction", IEEE Transactions on Electron Devices, Vol. 43, No. 11, November 1996
WML	BS	Hart et al., "Stroboscopic phase-shifting interferometry for dynamic characterization of optical MEMS", 18 th Congress of the International Commission for Optics, ICO XVIII August 2-6, 1999, San Francisco, CA USA, Optics for the Next Millennium, Technical Digest SPIE Volume 3749, pgs 468-469
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EXAMINER <i>Robinn</i>	DATE CONSIDERED <i>8/15/02</i>
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